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Active control of Resonant Cloaking in a Terahertz MEMS Metamaterial

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Abstract:

Metamaterials exhibiting exotic optical properties have played a significant role over the years in guiding the concept of invisibility cloaking from the realm of being fiction to reality. However, due to the difficulties in fabricating the 3-D cloaking devices and lack of exotic plasmonic materials at terahertz (THz) frequencies, experimental realization of cloaking phenomenon in the THz spectrum has been challenging. In this work, we report a new mechanism for invisibility cloaking based on the resonant scattering cancellation technique in a 2-D non-concentric composite metamaterial device consisting of a split ring resonator (SRR) and a microelectromechanical system (MEMS) reconfigurable closed ring resonator (CRR) at THz frequencies. A strong magnetic interaction between the SRR and CRR eliminates the scattering effects from the SRR at its fundamental eigen mode frequency, thereby making it invisible to the incident THz wave. Further, by voltage actuation of MEMS reconfigurable CRR, we demonstrate an active switching between the visible and cloaked states of SRR structure. The proposed technique provides a simple design and technique for realizing invisibility cloaks by utilizing the resonant near-field interactions in the subwavelength structures across microwaves to optical frequencies thereby circumventing the need for materials with complex geometry and exotic material parameters.

Introduction

Competence of engineering the effective material properties like permittivity and permeability of a medium using the electromagnetic metamaterials has inspired many fascinating aspects in science. These include the pioneering concept of super lens,^[1,2] negative refraction,^[3] invisibility cloaking,^[4-8] artificial magnetism^[9] and many more. Particularly, the experimental demonstration of invisibility cloak in the microwave^[10,11] and optical frequencies,^[12-15] which was once just a science fiction has been the hallmark achievement of metamaterials and optics in recent times. In general, the concept of invisibility implies reduction or cancellation of the scattering effects of the material of interest (also referred to as principal scatterer), which can be realized by tailoring the effective parameters such as permittivity and permeability of the surrounding medium. Over the years several cloaking techniques have been proposed using metamaterials and plasmonic structures^[16] that mainly include scattering cancellation technique (SCT),^[17-21] transmission line technique,^[22] transformation optics,^[4-8,23,24] quasi-conformal mapping techniques^[24,25] and anomalous localized resonances in plasmonic structures.^[26] In particular, SCT provides a simple design and structure without the need for complex geometries to realize invisibility effects across the infrared and visible frequencies. In SCTs, the low-loss isotropic plasmonic/metamaterial cover (also referred to as induced scatterer) operating at near plasmon frequencies is used to drastically reduce the scattering cross section of the principal scatterer. The condition for SCT dictates that the metamaterial cover and the principal scatterer should possess contrasting dielectric constants to induce opposing polarizabilities.^[18] Hence, for a proper choice of the radius of metamaterial cover, induced opposing dipoles on the metamaterial cover cancel out the dipoles of the principal scatterer, thereby making it invisible to the incident light. Despite the favorable features such as non-resonant and isotropic nature of the SCT based invisibility effects, the requirement on

the choice of materials possessing relatively low permittivity ($\epsilon_r < 1$) values makes it extremely difficult to realize across the broad range of electromagnetic frequencies.

Terahertz (THz) part of the electromagnetic spectrum is regarded as the technologically significant spectral domain that bridges the gap between the high speed electronics and photonics. Most of the cloaking techniques proposed so far rely on either the choice of cloaking material possessing exotic properties or complex 3-D design requirements, which makes it extremely difficult to realize the invisibility cloak effects in the THz part of the electromagnetic spectrum. One of the first experimental demonstration on invisibility cloak at THz frequencies was shown using a triangular 3-D cloak fabricated by using the projection microstereolithography process.^[27] Recently, few designs based on the 3-D carpet cloak in the THz frequencies were proposed, however they are difficult and non-trivial to realize experimentally.^[28] One of the possible way to circumvent the existing limitations is to extract the strong resonant interactions within the composite medium in planar 2-D structures to drastically eliminate the scattering effect of one of the resonant structures, which works on the principal of SCT to make the resonant structure invisible to the incoming beam. Realizing 2-D designs for the cloaking devices enable easy and large area fabrication that would enhance the possibility of practical realization of cloaking effects of the large samples across broad frequency spectrum. In this regard, 2-D metamaterials that offer strong near-field interactions can provide a good platform to realize resonant invisibility cloaking devices across broad range of frequency spectrum ranging from microwave to optical frequencies.

Here, we propose and experimentally demonstrate resonant scattering cancellation technique to realize invisibility cloaking of the resonant structure under the influence of the strong near-field interactions in a 2-D composite reconfigurable metamaterial medium. The induced magnetic coupling between the split ring resonator (SRR) and the closed ring resonator (CRR) creates a strong magnetic dipole that cancels out the opposing resonant magnetic dipoles of the SRR, thereby making the SRR invisible to the incoming THz wave. Unlike the traditional

SCT device that depends on the dielectric properties of the materials, the proposed composite metamaterial design uses the bianisotropy nature of the resonant SRR and the induced magnetic dipoles in realizing the invisibility effects within the device. Further, by adding an active structural reconfiguration feature to the CRR design by using the electrically tunable microelectromechanical systems (MEMS), we show a voltage controlled active switching between the visible and cloaked states of the SRR structure to the incident THz wave. MEMS cantilever based metamaterial provides unique prospects including active control of structural and optical properties of the metamaterial system, thereby enhancing their technological relevance. Previous demonstrations using MEMS designs have shown active control of chirality,^[29] anisotropy,^[30] perfect absorption,^[31] logical operations,^[32] and phase engineering^[33] in the system using either the thermal^[34,35] or electrical/voltage controls.^[36] In this work, we show active control of the MEMS actuated CRR structure in the out-of-plane direction of the sample that enables precise and dynamic control of the effective parameters of the metamaterial medium, thereby actively switching the cloaking effects in the system. In the literature, there are several works demonstrating the active control of metamaterial resonances using semiconductors such as GaAs,^[37] silicon,^[38] perovskites^[39] and other dynamic materials. However, MEMS offer distinctive feature of out-of-plane reconfiguration of metamaterial structure that allows us to probe and dynamically manipulate the near fields extended in the third dimension (z -axis) of the sample. By actuating the MEMS CRR structure in the third dimension through voltage control, we actively tune the bianisotropy in the proposed system to switch between the visible and cloaked states of the SRR, unlike the other planar devices including the previously studied concentric and non-concentric composite metamaterial structures.^[40, 41, 42]

Design and Fabrication Process

The proposed 2-D reconfigurable metamaterial structure is composed of a SRR placed non-concentrically within a MEMS actuated CRR. An artistic representation of the MEMS

actuated cloaking device is presented in Fig. 1, where in the snapped down (ON) state of the outer CRR structure, the resonant SRR structure becomes invisible to the incident THz waves. The scanning electron microscope (SEM) image of the fabricated sample is shown in the left inset of the Fig. 1. The device is fabricated using the complementary metal-oxide-semiconductor (CMOS) compatible process. The metamaterial is made of varying thicknesses of aluminium (Al) ($t = 300$ nm, 500 nm, 700 nm and 900 nm) on top of 50 nm aluminum oxide (Al_2O_3) deposited on the silicon substrate. The selective part of CRR is released by isotropically etching away the sacrificial silicon-di-oxide (SiO_2) layer from underneath the bimorph structure. Due to the residual stress in the bimorph layers, the cantilevers are bent up (released state), thereby creating an enhanced air gap between the substrate and bimorph cantilevers, as shown by the SEM image of the sample in the inset of Fig. 1 (details on the design and fabrication process are given in the experimental and methods section). The unit cell dimensions of the sample are given in the right inset of Fig. 1, where the total length of SRR is half that of the MEMS actuated CRR, with their metal arms separated by a coupling distance of $d = 1$ μm , when the device is in ON state. The out-of-plane actuation of the released arm of the CRR structure is achieved through electrostatic control, by applying voltage (V_{DC}) across the Al metal lines and low resistivity silicon substrate (>1 $\Omega\text{-cm}$). The Al_2O_3 layer in the bimorph ($\text{Al}_2\text{O}_3/\text{Al}$) structure electrically isolates the metal interconnect lines and the Al layer of CRR cantilevers from the substrate when the device is in its ON state and this allows for the voltage controlled out-of-plane actuation of the CRR cantilevers.

Results and Discussion

The fabricated composite MEMS metamaterial device is experimentally characterized using the terahertz time domain spectroscopy (THz-TDS) system for both ON (snapped) and OFF (released) configurations of the device at the normal incidence angle of the THz wave that is polarized parallel (E_x) to the gap bearing arm of the SRR (measurement procedures are provided in the experimental and methods section). The measured THz transmission spectra

for the ON and OFF voltage states of the device are given in Fig. 2(a) along with the corresponding SEM image of the device configuration. As shown, in the OFF (released, $V_{DC} = 0$ V) state of the CRR cantilevers, the transmission spectrum exhibits a strong coupling behavior signifying the mode hybridization of the SRR and the CRR resonances leading to a narrow band transmission peak at 1.1 THz. This configuration represents the widely studied metamaterial induced transparency effects,^[40,41,42] where the sharp inductive-capacitive (LC) resonance feature of the SRR and the broad dipole resonance of the CRR appearing at the same resonance frequency exhibit Fano-type of destructive interference mechanism, leading to a sharp transmission window at the resonance frequency.^[43] The appearance of transparency peak in the spectrum signifies a strong influence of the eigen (LC) resonance of the SRR in the composite MEMS metamaterial structure. As the CRR cantilever is snapped down (ON state, $V_{DC} = 30$ V) on the substrate, the transparency peak completely disappears and a strong dipole type of resonance is observed in the transmission spectrum (shown by the red line). Numerical simulations were carried out using the Computer Simulation Technology (CST) microwave studio frequency solver to precisely elucidate the near- and far-field optical characteristics of the metamaterial structure for the ON (snapped) and OFF (released) states of the CRR cantilevers and the obtained transmission spectra are shown in Fig. 2(b). The material parameters and the numerical methods followed in the simulations are described in the methods section. The voltage states (V_{DC}) in the experiments can be expressed in terms of release angle (θ_R) of the CRR cantilever, where $V_{DC} = 0$ V (OFF) and 30 V (ON) corresponds to $\theta_R = 1^\circ$ (released, OFF) and 0° (snapped, ON), respectively. The curves shown in green squares and the red circles represent the OFF (1°) and the ON (0°) states of the CRR cantilever in the composite structure and are in good agreement with the corresponding measured spectra shown in Fig 2(a). Further, simulations were carried out for the individual (uncoupled) SRR and the CRR structures possessing the same unit cell dimensions and

periodicity as specified in Fig. 1 and the resulting transmission spectra are shown by orange-dash and blue-dashed lines, respectively in Fig. 2(b). Particularly, the LC resonance feature of SRR coincide with the low frequency hybridized mode of the composite MEMS metamaterial structure in the OFF state ($\theta_R = 1^\circ$) of CRR, whereas in the ON state ($\theta_R = 0^\circ$), the dipole resonance of CRR alone precisely overlaps with the observed broad dipole type feature in the composite MEMS metamaterial structure. Further, the phase of the propagating wave passing through the composite MEMS metamaterial for ON ($\theta_R = 0^\circ$) state shows no distortion with respect to the phase of the wave passing through the CRR alone, as shown in the inset of Fig. 2(b). On the other hand, for OFF state ($\theta_R = 1^\circ$) of composite MEMS metamaterial device, due to the influence of SRR scattering, the phase profile and hence the wavefront of the propagating THz wave is strongly altered (shown by green line). This confirms that the SRR present in the composite MEMS metamaterial in the ON state of the device does not alter the phase or wavefront of the propagating THz waves, and thus becomes invisible. This far-field observation clearly highlights annihilation of the SRR effect under the influence of strong near-field magnetic coupling with the adjacent CRR arm.

Cancellation of the SRR effect seen at the far-field spectra is further supported and clearly elucidated by the nature of near-field electric, magnetic and surface current distributions shown in Fig. 2(c)-(e) for OFF and ON states of the composite MEMS metamaterial device. In the OFF (released) state, the electric and magnetic fields are confined in the gap and around the metal arm of the SRR structure, respectively, indicating a strong resonant interaction of the SRR with the incoming THz wave of polarization E_x . As the CRR is snapped down onto the substrate, with the separation (d) between the SRR inductive arm and CRR arm being 1 μm , the confined electric and magnetic fields within the SRR structure disappears, thereby making the resonant SRR structure invisible to the incident E_x polarized THz wave. The mechanism of the observed resonant invisibility is understood by studying the surface current

distributions shown in the Fig. 2(e). In the OFF state, SRR shows a strong surface current distribution, signifying a stronger coupling of SRR with the incident THz wave, where most of the near-field energy is confined within the SRR structure. In the ON state, once the inductive arm of the SRR is in a close proximity ($d = 1 \text{ } \mu\text{m}$) of the CRR arm, strong opposing currents develop on the outer edge of the SRR and the CRR arms. These currents give rise to a strong magnetic interaction thereby inducing a magnetic field between the SRR and CRR arms with their magnetic dipoles aligned perpendicular (H_z) to the plane of the sample. The induced surface current (magnetic dipole) possesses the opposite sign and greater strength with respect to the intrinsic surface currents (magnetic field) of the SRR structure, thereby cancelling the surface currents (near-field effects) of the SRR structure. Further insights on magnetic interactions in the composite metamaterial structure have been discussed in our previous study^[42] that relates the cancellation of the SRR effect to the ratio of the magnetic fields and the phase reversal point of the magnetic dipoles in the strong magnetic coupling regime of the medium. Hence, the strong resonant magnetic interaction between the SRR (principal scatterer) and the CRR (induced scatterer) results in the cancellation of SRR magnetic dipoles thereby making it invisible to the incoming THz wave, which is a resonant magnetic analogue to the scattering cancellation techniques widely proposed for realizing the cloaking effects using the plasmonic structures.

Further studies were carried out to understand the influence of the coupling effects in the composite MEMS metamaterial device on the transmission characteristics and the effective parameters of the medium for varying metal thicknesses (t) and the corresponding release angle (θ_R) of the CRR structure. In Fig. 3(a), the measured transmission spectra for varying metal thicknesses (t) are shown, where with decreasing t in the released state of the sample, the spectra exhibit mode hybridization characteristic possessing gradual increase in LC resonance strength and blue shift in the frequency of the dipole resonance of the CRR structure. Change in the metal thickness corresponds to the change in the release angle of the

CRR, where thinner metal will result in larger release angle of the cantilever of the same length.^[44] Hence, in the OFF state, the device with 300 nm metal thickness will possess larger release angle (θ_R) and hence larger blue shift in the dipolar resonance of CRR structure. To further support this observation, numerical simulations were carried out by varying the release angle (θ_R) of the CRR cantilever and the resulting transmission spectra are shown in Fig. 3(b). For $\theta_R = 0$, the transmission spectrum shows a broad dipolar resonance and with increasing θ_R , it exhibits similar behavior as observed in the experiments that shows gradual increase in the strength of the LC resonance of SRR and large blue shift in the dipole resonance of the CRR for the angle of $\theta_R = 50^\circ$. At this larger release angle the SRR decouples from the strong magnetic influence of the CRR arm and hence becomes visible as it interacts strongly with the incoming THz wave.

It is well established that the major factors governing the invisibility cloaking effects are the effective parameters of the medium such as electric permittivity (ϵ) and magnetic permeability (μ). Here to further support our claims, we extract the complex permittivity ($\epsilon = \epsilon_{Re} + i \epsilon_{Im}$) and permeability ($\mu = \mu_{Re} + i \mu_{Im}$) of the composite MEMS metamaterial structure for varying θ_R of CRR as discussed in Fig. 3(b). The effective parameters of the medium were calculated using the expression for the impedance (z) and the refractive index (n) discussed in Ref. ^[45], by using the scattering (S) parameters S_{11} (reflected) and S_{21} (transmitted) extracted from the numerical simulations. Later, the complex electric permittivity and complex magnetic permeability were calculated by using the formula $\epsilon = \frac{n}{z}$ and $\mu = n \cdot z$, respectively and are plotted in Fig. 4 for varying θ_R of CRR. For $\theta_R = 0^\circ$, a broad resonance spectrum near 1 THz is seen that exhibits strong magnetic response resulting in anomalous change in the magnetic permeability of the medium (black line in Fig. 4 (c) and (d)), on the other hand, the electric permittivity of the medium shows no response (black line in Fig. 4 (a) and (b)) at the

resonance. This result justifies that the broad resonance feature in the composite MEMS metamaterial medium is rich in the magnetic response due to the strong magnetic interactions between the inductive arm of the SRR and the CRR arm in the ON state ($\theta_R = 0^\circ$) of the device, that results from the strong bianisotropy of the system. Hence, in this configuration (i.e. $\theta_R = 0^\circ$), the composite device behaves as a magnetic medium showing the negative values for $\text{Re}(\mu)$ in some part of the frequencies near the resonance as shown in Fig. 4(c). As the release angle (θ_R) is increased, the magnetic permeability (μ) of the medium gradually decreases, meanwhile the response of electric permittivity (ϵ) in the medium starts to grow stronger in strength. At larger angle (i.e. $\theta_R = 50^\circ$), the electric permittivity in the medium dominates the resonance response (orange line in Fig. 4(a) and (b)), whereas the strength of magnetic permeability (μ) becomes insignificant and the $\text{Re}(\mu)$ takes the positive values (orange line in Fig. 4(c)) signifying annihilation of magnetic response in the system. This observation is true since, at the larger angles SRR resonance starts to show the dominating effects, where the resonant effects are dominated by the electric response showing the negative values and anomalous change in the $\text{Re}(\epsilon)$. Hence, by actively tuning the release angles (θ_R) of the CRR cantilever using the voltage input enables the gradual switching between the electric and magnetic response of the composite MEMS metamaterial medium, thereby aiding the dynamic control of the invisibility cloaking effect in the system.

The effect of incidence angle on the cloaked state of the device is illustrated in Fig. 5, where we present the numerically calculated far-field transmission response and the near-field energy distribution in the composite MEMS metamaterial device for varying angle of incidence (θ_x, θ_y) of the incoming THz beam. Angle of incidence of the THz beam is separately varied along the x - (θ_x) and the y -axis (θ_y) of the sample. For θ_x variation, the H -component of the THz wave always remain in the plane (along y -axis) of the sample and the E -component forms a projection along the z -axis (out-of-plane) of the sample, whereas for θ_y ,

variation, the E -component of the THz wave remains in the plane (along x -axis) and the H -component forms a projection along the z -axis (out-of-plane) of the sample. Varying the incidence angle (θ_x) by keeping the H -component of THz wave in the plane of the sample results in the gradual decrease of resonance linewidth in the far-field transmission spectra with no significant change in its resonance amplitude, as shown in Fig. 5(a). Meanwhile, the near-field confinement of the magnetic distribution for varying θ_x shown in Fig. 5(b) highlights gradual increase in the magnetic field confined in the region between the SRR and CRR arms, which therefore results in the significant reduction of the linewidth of the far-field resonance spectra (Fig. 5(a)). Absence of the magnetic field confinement within the SRR for increased incident angles θ_x affirms that the invisibility of SRR is insensitive (independent) to angle of incidence (θ_x) along the x -axis of the sample. The experimentally measured far-field transmission spectra for varying angle of θ_x are shown in the inset of Fig. 5(a) that match well with the resonance narrowing trend seen in the simulation data, where for $\theta_x = 45^\circ$ (green line), the linewidth of the resonance becomes narrower than for the angle $\theta_x = 5^\circ$ (red line). On the other hand, when the angle of incidence is varied along the y -axis (θ_y), linewidth of the far-field spectra becomes narrower till $\theta_y < 80^\circ$, as shown in Fig. 5(c), which shows a similar trend in the resonance behavior seen for θ_x variation. At $\theta_y = 80^\circ$, the far-field spectrum shows a strong mode splitting characteristic (green line, Fig. 5(c)) indicating reappearance of SRR response in the composite MEMS metamaterial device that can be clearly shown by the enhanced magnetic fields near the inductive arm of the SRR shown in Fig. 5(d) for $\theta_y = 80^\circ$. At large θ_y , rather than the electric (E)-component of the THz wave, it is the magnetic (H)-component of the field that directly excites the SRR resonator in the system, thereby making it visible to the incident THz wave. The optical response of the sample at larger incident angle (θ_x and $\theta_y > 45^\circ$) is not realistic in the experimental conditions at THz frequencies, because of the violation of effective and homogenous medium conditions for the fabricated planar

sample. Hence, the reported resonant invisibility of SRR structure to the THz wave with an added advantage of insensitiveness to the angle of incidence benefits the realization of plasmonic/metamaterial coupling induced cloaking devices at terahertz and higher frequencies, which operates on the principle of resonant scattering cancellation techniques.

Conclusion

In summary, we demonstrated an active resonant invisibility of metamaterial split ring resonator (SRR) in a two-dimensional planar MEMS metamaterial device composed of nonconcentric SRR and CRR structures at terahertz frequencies. We showed that strong magnetic interaction between the SRR (principal scatterer) and the CRR (induced scatterer) induces the cancellation of magnetic dipole of the SRR. The results demonstrated active switching between the visible and cloaked states of the SRR structure using the voltage states $V_{DC} = 0$ V and 30 V, respectively. Further, active tailoring of the medium parameters such as permittivity and permeability, showed that the device can be switched from magnetic medium to non magnetic medium with permeability values of the medium changing from negative to positive values. The reported invisibility effects depend on the polarization of the incoming THz beam due to the structural anisotropic nature of the SRR (principal scatterer) itself, however, they are insensitive to the incidence angle of the incoming beam. Moreover, the proposed technique provides a new platform to realize active control of invisibility cloaking phenomena in planar metamaterial structures across the wide range of electromagnetic spectrum. The results show useful prospects in real world applications as resonant switches, active slow-light devices, modulators and active band pass filters across far-infrared frequencies.

Experimental and Methods Section:

Design: The chosen design of placing the SRR and CRR in the non-concentric arrangement (coupling distance $d = 1$ μm) enables strong inductive (magnetic) interactions in the system

that is greater than the strength of the magnetic dipoles in the SRR structure. This creates stronger and opposing scattering fields in the vicinity of the SRR (principal) scatterer that cancels the weakly scattered fields from the SRR, thereby making it invisible to the resonant THz wave. These are subwavelength structures and the spectroscopically probed area of metamaterial medium consists of nearly 5028 resonators arranged periodically within the spot size (4 mm) of the incident THz beam, which satisfies the homogeneity condition to enhance the cloaking effects seen in the far-field for a single composite metamolecule unit cell of periodicity 50 μm .

Fabrication Process: The composite MEMS metamaterial was fabricated using a complementary metal-oxide-semiconductor (CMOS) compatible process as described below. First, the lightly doped 8 inch low resistivity silicon substrate of 725 μm thickness was cleaned and a 100 nm thick sacrificial SiO_2 layer was deposited using low pressure chemical vapor deposition (LPCVD) process. Following this, conventional photolithography process was used to pattern the anchor region. With the designed pattern, the parts of sacrificial SiO_2 for anchor regions were dry etched using reactive ion etching process. After this, a 50 nm thick Al_2O_3 layer was deposited using the atomic layer deposition (ALD) process, followed by the sputter deposition of 300 nm, 500 nm, 700 nm and 900 nm thick Al. Note that the bimorph layers (Al/ Al_2O_3) were in physical contact with Si substrate at the anchor region, and in the remaining part of the wafer, it was on top of sacrificial SiO_2 layer. Then, the second photolithography step was carried out for defining the cantilevers and metal lines of metamaterial patterns. Following this, both Al and Al_2O_3 layers were dry etched to form the designed metamaterial. Finally, vapor hydrofluoric acid (VHF) was used to isotropically etch the SiO_2 sacrificial layer underneath the bimorph structures, thereby suspending it over the Si substrate with an air gap between them. At the anchor region, since the bimorphs were in physical contact with Si substrate, the VHF release process was not time controlled, and this ensured higher yield of the devices. Due to the residual stress in the bimorph cantilevers of

CRR structure, the released cantilevers were bent up, thereby increasing the initial tip displacement.

THz Measurements: The composite MEMS metamaterial is optically characterized using the conventional GaAs photoconductive switch based THz-time domain spectroscopy system operating in the transmission mode. The wire bonded metamaterial sample is positioned at the focus of the THz beam. The electrical connections to the CRR structures are established using a DC voltage source. The measurements were performed for the voltage states of $V = 0$ V (OFF) and $V = 30$ V (ON) applied on the CRR cantilever with the THz wave of beam spot 4 mm is incident at the normal angle on the sample and the transmitted THz pulse is captured using the THz detector connected to the lock-in amplifier. THz response through the bare silicon substrate is measured for the referencing the signal through the sample. In the post processing steps, the detected THz pulses measured through the sample and the bare substrate are fast Fourier transformed (FFT) to obtain the corresponding THz spectra. Later, the transmitted THz spectrum through the sample ($T_s(\omega)$) is normalized with respect to the transmission through the substrate ($T_R(\omega)$), i.e. $T(\omega) = T_s(\omega)/T_R(\omega)$ and the normalized spectrum is shown in the Figs. 2(a) and 3(a).

Numerical Simulations: Finite-difference time-domain (FDTD) numerical simulations were conducted to calculate the far-field THz transmission spectra and the confined electric near-fields and surface current distributions showing the visible and invisible (cloaked) state of the SRR for the E_x polarization of the THz wave. Full-field electromagnetic wave simulations were performed using the commercial simulation software Computer Software Technology (CST) Microwave studio. For the material property, aluminum (Al) of varying thickness 300, 500, 700 and 900 nm were modeled as lossy metal with conductivity of 3.57×10^7 S/m. Aluminum oxide and Silicon were modeled as lossless dielectric materials with dielectric constant of 9.5 and 11.9, respectively. In the simulation, a single unit cell of the metamaterial structures was simulated with unit cell boundary conditions employed in axial directions

orthogonal to the incident waves. The perfectly matched layers were applied along the propagation of the electromagnetic waves. Plane waves were incident into the unit cell from the port on the metal side, while the transmission spectrum was determined from the probe placed at the other side of metamaterial. The deformation angles for the cantilevers were used to tilt the metal cantilevers that established the congruence between the values of applied voltages (V) and the release angle (θ_R) used in the simulations. In the meanwhile, field monitors were used to collect the electric fields, magnetic fields and the respective surface currents at 1.1 THz frequency for $\theta_R = 1^\circ$ (released, OFF) and 0° (snapped, ON) state of the device.

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Figures

Figure 1. Artistic representation of the MEMS incorporated composite reconfigurable metamaterial structure consisting of outer MEMS closed ring resonator (CRR) and the inner split ring resonator (SRR), where the latter becomes invisible to the incoming THz wave in the ON ($V_{DC} = 30$ V) state of the device. Left inset shows the scanning electron microscope (SEM) image of the fabricated composite MEMS metamaterial device in its released (OFF, $V_{DC} = 0$ V) state. The right inset depicts the unit cell dimensions of the metamaterial design with a square period of $50 \mu\text{m}$.

Figure 2. (a) Experimentally measured THz transmission spectra of the composite MEMS metamaterial device without (green line) and with (red line) the voltage (V_{DC}) applied across the metal lines and the silicon substrate. The measurements are performed on the sample with the metal thickness $t = 900$ nm. The insets show SEM images of OFF and ON states of the metamaterial with $V_{DC} = 0$ V and 30 V, respectively. (b) Depicts the numerically simulated THz transmission spectra for the composite MEMS metamaterial and the individual CRR and SRR. The spectrum for the release angle of CRR (θ_R) of 1° and 0° respectively correspond to the OFF and ON states of the experimentally measured data shown in (a). The inset represents the phase spectra of the transmitted THz wave for CRR alone and ON/OFF state of the composite MEMS metamaterial device. (c) Electric field, (d) magnetic field and (e) surface current distributions shown for the OFF and ON state of the MEMS metamaterial highlighting the cancellation of SRR fields in the ON state.

Figure 3. (a) Depicting the experimentally measured THz transmission spectra for the composite MEMS metamaterials possessing different metal thicknesses ($t = 300, 500$ and 700 nm) in their OFF state and for 300 nm thick metal in its ON state. (b) Numerically simulated transmission spectra for the composite MEMS metamaterial device for varying release angle (θ_R) of the outer CRR structure. The change in the metal thickness of the CRR inversely corresponds to the change in the release angles- thinner the metal, higher is the release angle of CRR.

Figure 4. Numerically extracted (a), (c) real and (b), (d) imaginary parts of effective permittivity (ϵ) and permeability (μ) of the composite MEMS metamaterial medium for varying release angles (θ_R) of CRR, respectively. The medium exhibits strong magnetic response in its ON (cloaked) state (black line in (c) and (d)), where the electric response is negligible (black line in (a) and (b)). In the OFF (released) state, as the release angle (θ_R) increases, the electric response of the medium dominates (orange line in (a) and (b)) and the magnetic response diminishes (orange line in (c) and (d)) at the resonance.

Figure 5. Numerically simulated (a) THz transmission spectra and (b) magnetic field distributions for the composite MEMS metamaterial sample for varying angle of incidence (θ_x) of the THz beam along the x -axis, which respectively shows narrowing of the resonance and increase in the strength of magnetic interactions between SRR and CRR for increasing θ_x . The inset figure in (a) depicts the measured transmission spectrum through the composite MEMS metamaterial sample for varying θ_x . (c) and (d) show the numerically calculated transmission spectrum and the magnetic field distribution for the varying angle of incidence (θ_y) along y -axis showing the reappearance of SRR effect for large angle ($\theta_y = 80^\circ$).